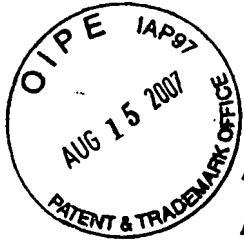


*Dr***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Yair EIN-ELI et al  
Application No. : 10/750,969  
Filed : January 5, 2004  
Title : TEXTURING A SEMICONDUCTOR MATERIAL USING  
NEGATIVE POTENTIAL DISSOLUTION (NPD)

Group/Art Unit : 1742  
Examiner : Nicholas A. Smith  
Attorney Docket No. : 27054

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

Sir:

This is in response to the United States Patent and Trademark Office Action mailed May 16, 2007, which response is being made on or before August 16, 2007, and for which no extension of time fee is due.

Applicant submits this response for entry into the record, in which:

**Remarks begin on page 2**